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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/525,502	02/23/2005	Hiroshi Mimura	1009682-000144	7858
21839 7590 05/14/2009 BUCHANAN, INGERSOLL & ROONEY PC POST OFFICE BOX 1404 ALEXANDRIA, VA 22313-1404				
EXAMINER REYNOLDS, STEVEN ALAN				
ART UNIT 3728		PAPER NUMBER		
NOTIFICATION DATE 05/14/2009		DELIVERY MODE ELECTRONIC		

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Notice of the Office communication was sent electronically on above-indicated "Notification Date" to the following e-mail address(es):

ADIPFDD@bipc.com

Office Action Summary

Application No.

10/525,502

Applicant(s)

MIMURA ET AL.

Examiner

Steven Reynolds

Art Unit

3728

Period for Reply -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 26 March 2009.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 8, 10, 11 and 13-17 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 8, 10, 11 and 13-17 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
- Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- 1) ☐ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☐ Information Disclosure Statement(s) (PTO/S508)
- 4) ☐ Interview Summary (PTO-413)
- 5) ☐ Notice of Informal Patent Application
- 6) ☐ Other: _____
- Paper No(s)/Mail Date _____

DETAILED ACTION

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 3/26/2009 has been entered.

Claim Objections

2. Claims 10 and 11 are objected to because of the following informalities:

In claim 10, lines 2-3, the limitation "an attachment hole for the attachment cylinder is formed in, at least, one of the container body and the door" was already presented in claim 8. Examiner suggests that this limitation be deleted from claim 10.

In claim 11, lines 2-4, the limitation "the attachment cylinder has a flange projected from the outer peripheral surface thereof for hooking the attachment hole, the filter support structure is formed of a pair of separate support pieces opposing each other" was already presented in claim 8. Examiner suggests that this limitation be deleted from claim 11.

Appropriate correction is required.

Claim Rejections - 35 USC § 103

3. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
4. Claims 8, 10 and 11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wu et al. (US 6,732,877) in view of Ejima et al. (US 6,032,802). Wu discloses a substrate storage container including: a container body (8) of a front-opening box for storing substrates therein; a door (82) for opening and closing the front of the container body; an attachment hole (80) formed in at least one of the container body and the door; and an inner-pressure adjustment device (air vent plug arrangement – See Fig. 2) attached to the attachment hole for adjusting the pressure inside the container body closed with the door, wherein the inner-pressure adjustment device comprises an attachment cylinder (cylinder formed from 12 and 41) formed in cylindrical shape having a first opening (opening at edge 10) at one end face and a second opening (opening at 43) smaller than the first opening at an other end face, a hollow filter support structure (2/42) fitted into the attachment cylinder and a filter (5) held inside the filter support structure; wherein the filter support structure is composed of a pair of support pieces (2 and 42) arranged opposite to and attached to each other, each of said pair of support pieces having an approximately T-shaped section (the bottom portion of element 2, which comprises portions 221 and 223, is considered to be T-shaped; and element 42 in combination with surface 43 is considered to be T-shaped). Wu discloses the claimed invention except for the specific material of the attachment cylinder, the attachment cylinder being removable, and the pair of juxtaposed flanges on the attachment cylinder.

Regarding the specific material of the attachment cylinder, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have formed the attachment cylinder from any material such as plastic (which can be considered to be elastic due to its material properties) in order to have the desired strength. It has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. *In re Leshin*, 125 USPQ 416.

Regarding the attachment cylinder being removable and having a pair of juxtaposed flanges, Ejima teaches a substrate storage container comprising a removable filter assembly (27 – See Fig. 2) including a pair of juxtaposed flanges (30) integrally formed on an outer periphery thereof for the purpose of removably attaching the filter assembly to an opening (26) with cutouts (26A). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have substituted the permanent engagement means (i.e. edge 10 being fixedly fastened to the air vent 80 by ultrasonic welding) of Wu with the engagement means (flanges 30 and cutouts 26A) as taught by Ejima in order to allow for the inner-pressure adjustment device to be removable so it can be replaced if necessary.

Regarding claims 10 and 11, Wu-Ejima discloses a guide rib (rib surrounding hole 89 – See Fig. 2) for the inner-pressure adjustment device is formed near the attachment hole; and each supporting piece having an approximately cylindrical form, and the opposing parts of the supporting pieces are extended outwards with respect to the width direction, forming filter holders.

5. Claims 13 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wu et al. (US 6,732,877) in view of Ejima et al. (US 6,032,802) as applied to claim 8 above, and further in view of Yamamoto (US 5,960,960). As described above, Wu-Ejima discloses the claimed invention except is silent about the specifics of the shelf elements on the interior sides of the container body. However, Yamamoto teaches a substrate storage container comprising shelf elements which include a part of the substrate contact area of each shelf element that is formed with a low-frictional resistance portion (203 – See column 3, lines 5-9) for the purpose of allowing the substrate to be easily removed from the shelf elements. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have provided the shelf elements of Wu to include a low-frictional resistance portion as taught by Yamamoto in order to allow the substrates to slide into the shelf elements smoothly and to be removed more easily.

Regarding claim 17, Wu-Ejima-Yamamoto discloses the claimed invention except is silent the specifics of the low-frictional resistance portion of the shelf elements. It would have been obvious to one having ordinary skill in the art at the time the invention was made to have made the low-frictional resistance portions from a material having any roughness including 0.2a or above in order to allow the substrates to be smoothly inserted/removed. It has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. *In re Leshin*, 125 USPQ 416.

6. Claim 15 is rejected under 35 U.S.C. 103(a) as being unpatentable over Wu et al. (US 6,732,877) in view of Ejima et al. (US 6,032,802) as applied to claim 8 above, and further in view of Nyseth (US 5,586,658). As described above, Wu-Ejima discloses the claimed invention except is silent about the specifics of the interior backside of the container. However, Nyseth teaches a substrate container comprising a backside (interior surface of 18 - See Fig. 3 and Fig. 8) which includes grooves (grooves 115 on row 101 - See Figs. 2 and 8) with a sectional shape configured to be asymmetrical with respect to the substrate, and a lean constraint element (the grooves on row 102 can be considered lean constraint elements as they keep the substrate from leaning once the substrate is in the groove), in order to hold the substrate in place in the container. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have provided the interior backside of the container of Wu-Ejima with grooves and lean constraint elements as taught by Nyseth in order to better hold the substrates in place within the container.

7. Claim 14 is rejected under 35 U.S.C. 103(a) as being unpatentable over Wu et al. (US 6,732,877) in view of Yamamoto (US 5,960,960). Wu discloses a substrate storage container including: a container body (8) of a front-opening box for storing substrates therein; a door (82) for opening and closing the front of the container body; and an inner-pressure adjustment device (air vent plug arrangement - See Fig. 2) attached to, at least, one of the container body and the door, for adjusting the pressure inside the

container body closed with the door. Wu discloses the claimed invention except is silent about the specifics of the shelf elements on the interior sides of the container body.

However, Yamamoto teaches a substrate storage container comprising shelf elements which include a part of the substrate contact area of each shelf element that is formed with a low-frictional resistance portion (203 – See column 3, lines 5-9) for the purpose of allowing the substrate to be easily removed from the shelf elements. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have provided the shelf elements of Wu to include a low-frictional resistance portion as taught by Yamamoto in order to allow the substrates to slide into the shelf elements smoothly and to be removed more easily.

Wu-Yamamoto discloses the claimed invention except is silent the specifics of the low-frictional resistance portion of the shelf elements. It would have been obvious to one having ordinary skill in the art at the time the invention was made to have made the low-frictional resistance portions from a material having any roughness including 0.2a or above in order to allow the substrates to be smoothly inserted/removed. It has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. *In re Leshin*, 125 USPQ 416.

8. Claim 16 is rejected under 35 U.S.C. 103(a) as being unpatentable over Wu et al. (US 6,732,877) in view of Yamamoto (US 5,960,960) as applied to claim 14 above, and further in view of Nyseth (US 5,586,658). As described above, Wu-Yamamoto discloses

the claimed invention except is silent about the specifics of the interior backside of the container. However, Nyseth teaches a substrate container comprising a backside (interior surface of 18 - See Fig. 3 and Fig. 8) which includes grooves (115) with a sectional shape configured to be asymmetrical with respect to the substrate in order to hold the substrate in place in the container. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have provided the interior backside of the container of Wu-Yamamoto with grooves as taught by Nyseth in order to better hold the substrates in place within the container.

Response to Arguments

9. Applicant's arguments filed 3/26/2009 have been fully considered but they are not persuasive. Applicant argues that Yamamoto does not disclose the arithmetic average roughness as claimed. Since Yamamoto is silent about the specific material of the low-frictional resistance portions, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have made the low-frictional resistance portions from a material having any roughness including 0.2a or above in order to allow the substrates to be smoothly inserted/removed. It has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. *In re Leshin*, 125 USPQ 416.

Conclusion

10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Steven Reynolds whose telephone number is (571)272-9959. The examiner can normally be reached on Monday-Friday 9:30am - 4:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mickey Yu can be reached on (571)272-4562. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/S. R./
Examiner, Art Unit 3728

/Mickey Yu/
Supervisory Patent Examiner, Art
Unit 3728